

인공지능 기초 실습

Keonhyeok Park
Industrial AI Lab.

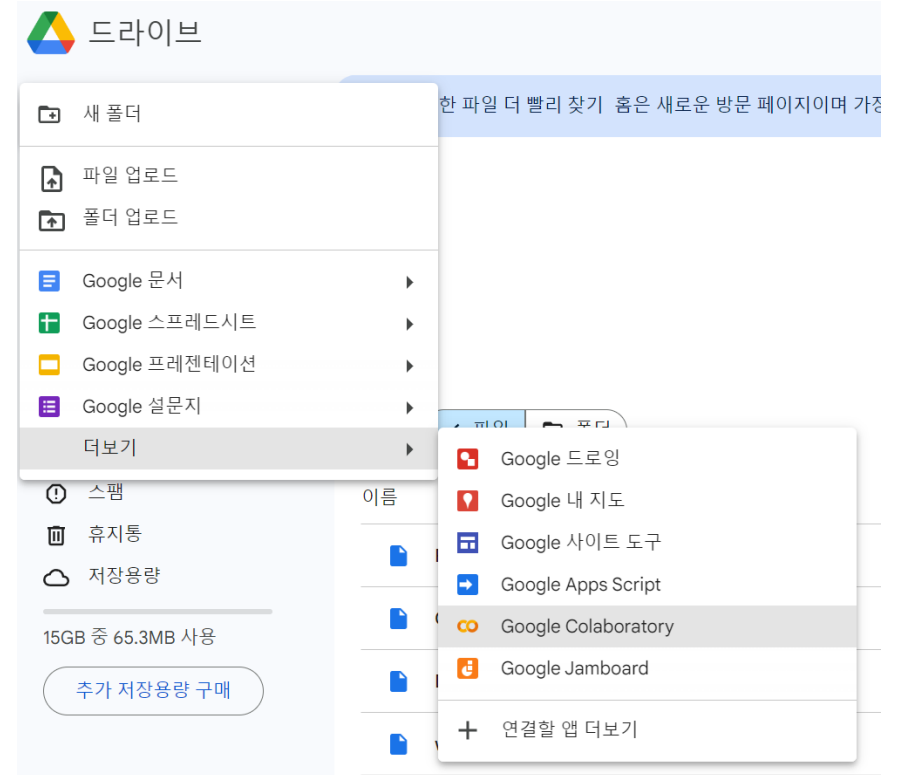
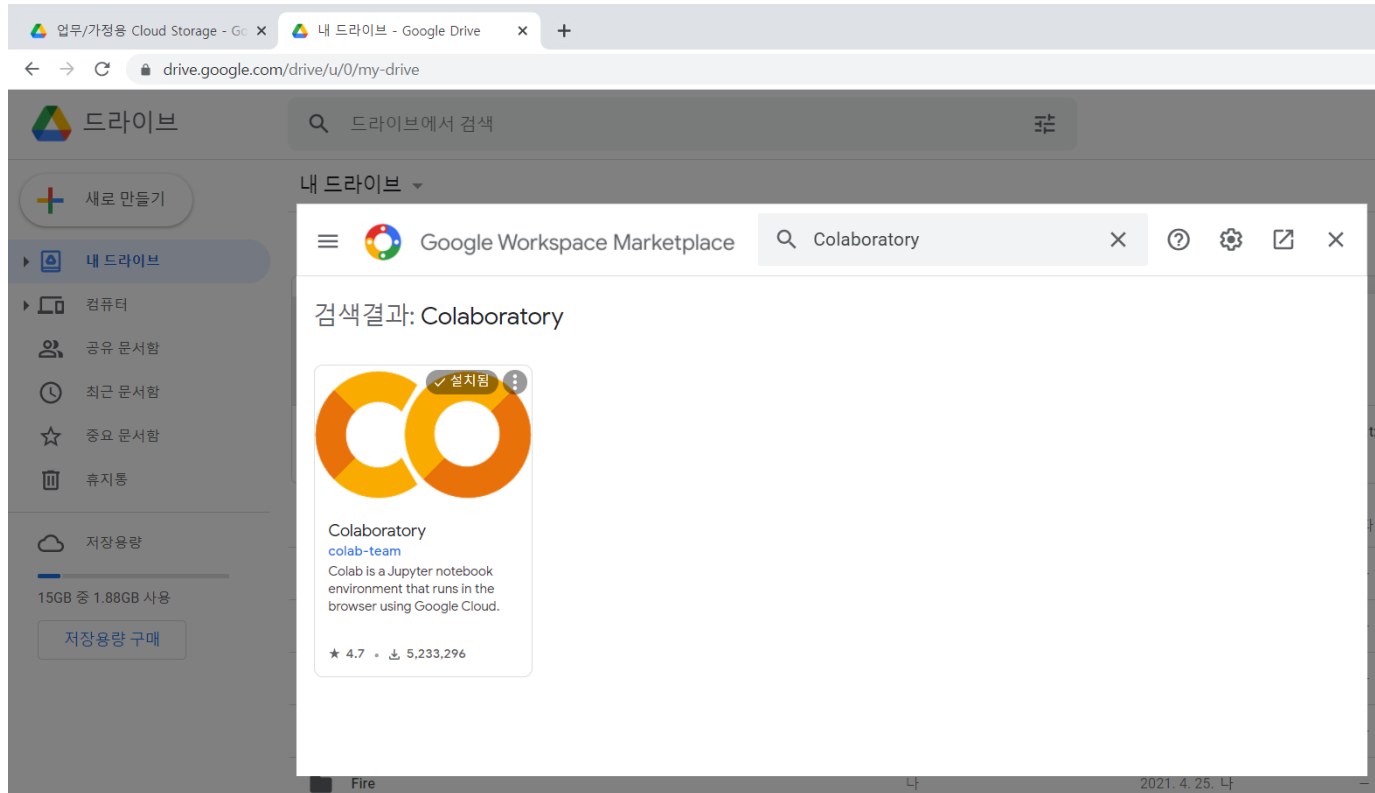
Contents

- 실습 환경 및 딥러닝 코드 준비
- 코드 실습
 - 실습 1: Regression (Injection Molding Dataset)
 - 실습 2: Classification (Wafer Failure Dataset)
 - 실습 3: Dimension Reduction (MNIST Dataset)

실습 환경 및 딥러닝 코드 준비

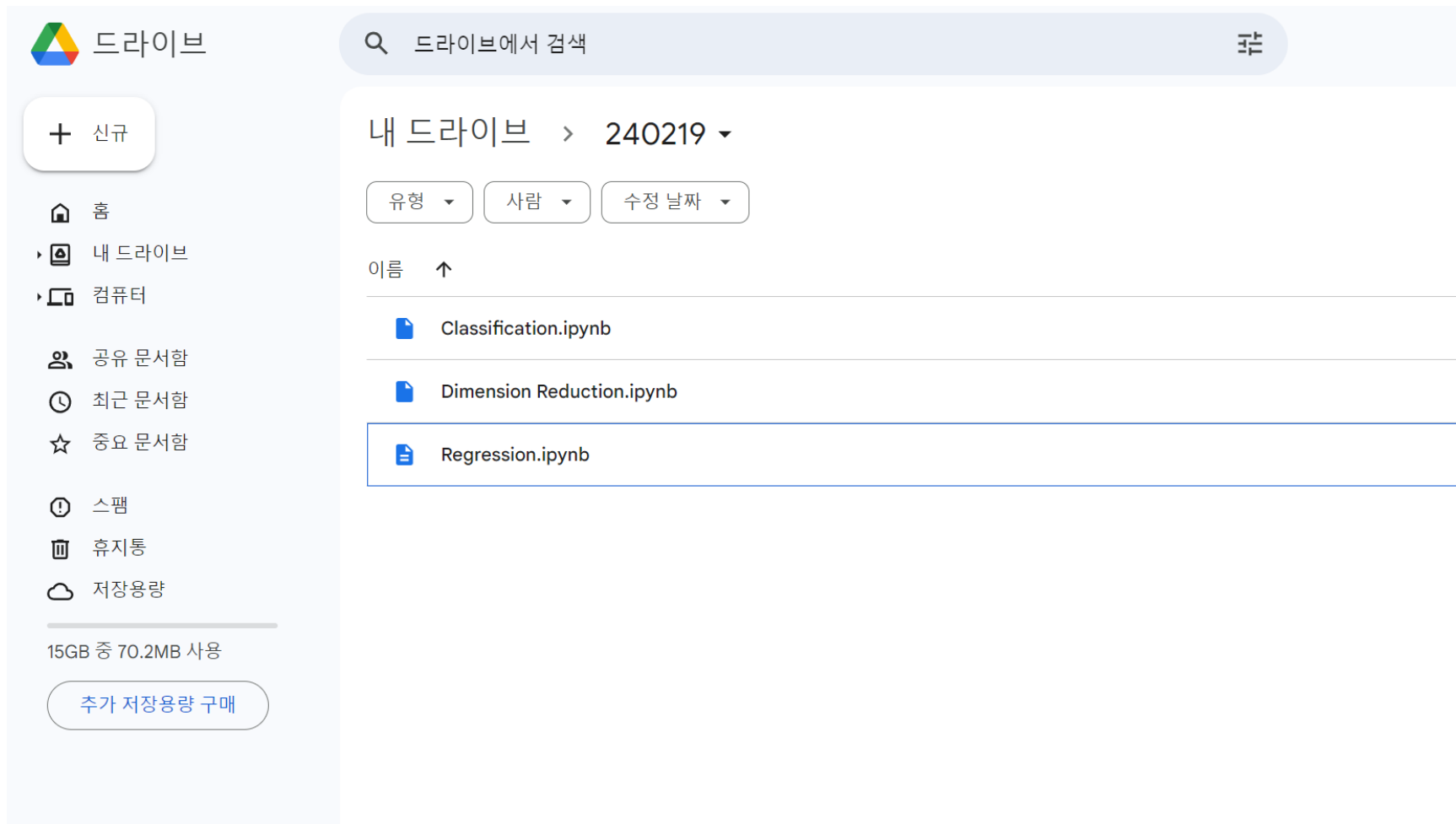
코랩 설치 방법

- https://www.google.com/intl/ko_KR/drive/ 로 이동하여 우측 상단에 [드라이브로 이동]을 클릭
- [새로 만들기 (신규)] -> [더보기] -> [연결한 앱 더보기] -> Colaboratory 설치



딥러닝 코드 준비

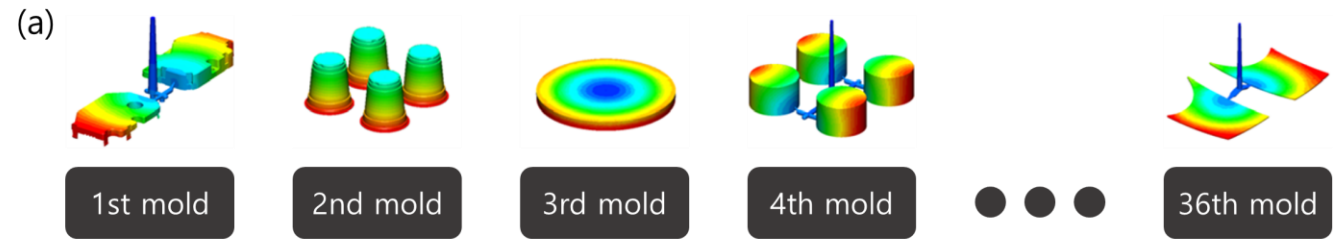
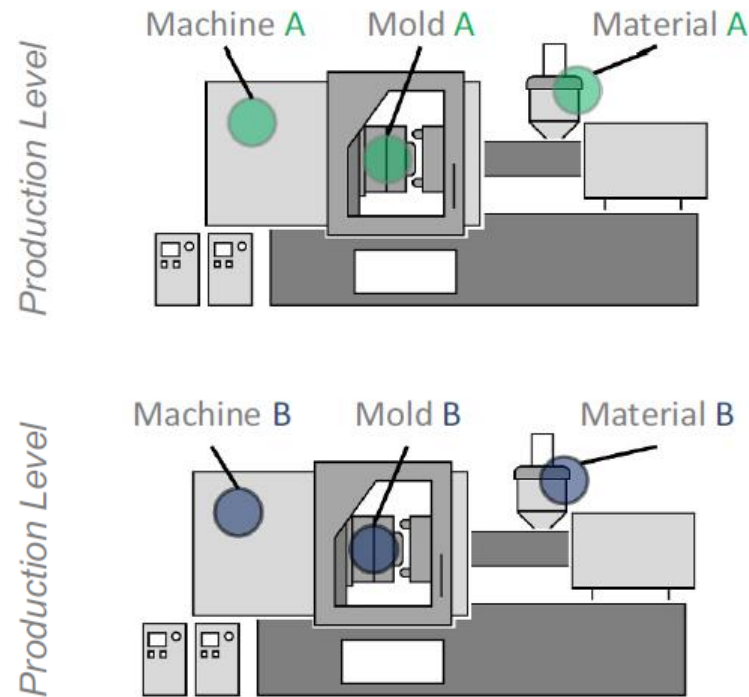
- Google [내 드라이브]에 딥러닝 코드 업로드



Regression (회귀분석)

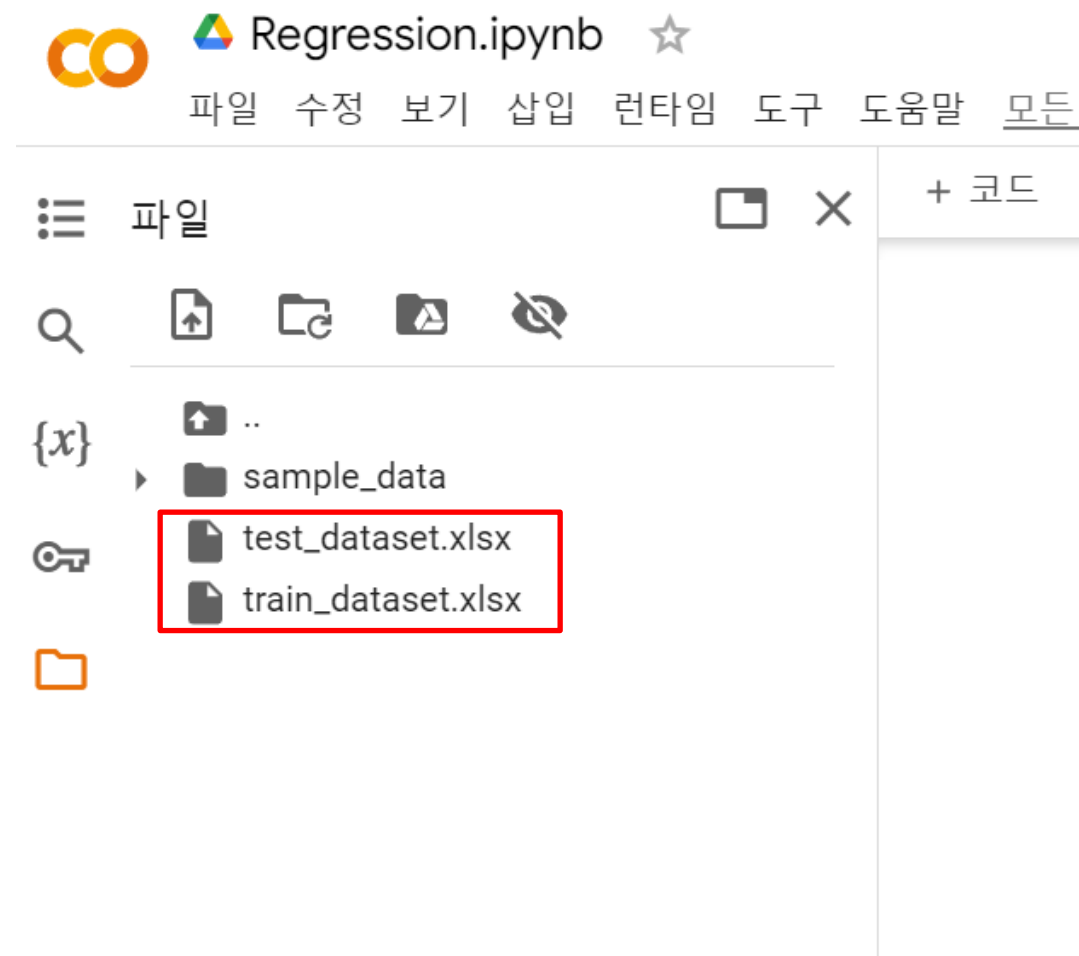
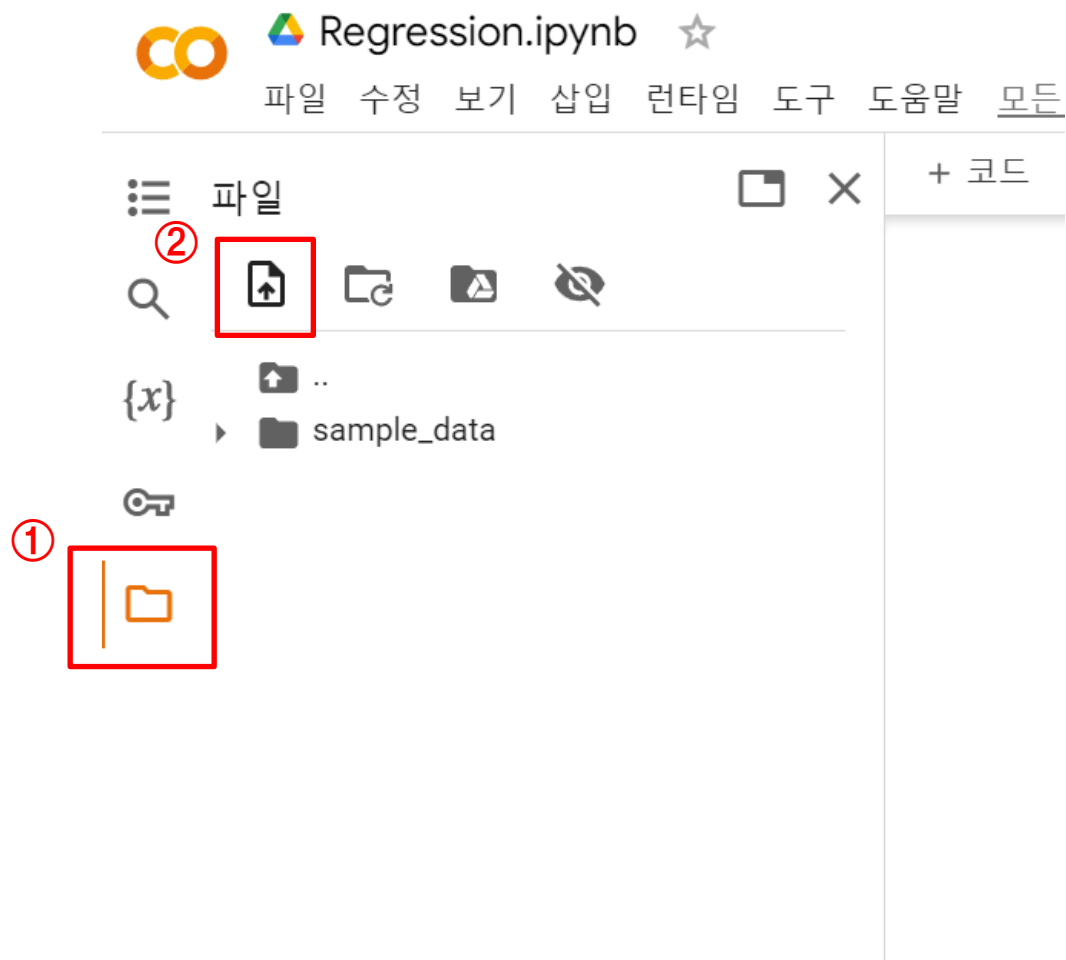
Injection Molding Process

- Multiphysics feature-based manufacturing process
 - Input (x): 32 Geometric features + 5 Process features
 - Output (y): Weight of the molded part (ground truth)



Geometric Features			Process Features
Cavity Volume	Runner Volume	Number of Cavities	Fill Time
Overall Surface Area	Cavity Surface Area	Runner Surface Area	Melt Temperature
Overall Projection Area XY	Overall Projection Area YZ	Overall Projection Area ZX	Mold Temperature
Max Part Thickness	Avg Part Thickness	Std Part Thickness	Packing Pressure
Max Flow Length	Min Flow Length	Avg Flow Length	Packing Time
Std Flow Length	Max Flow Length to Thickness	Min Flow Length to Thickness	
Avg Flow Length to Thickness	Std Flow Length to Thickness	Max Gate Hydraulic Diameter	
Min Gate Hydraulic Diameter	Avg Gate Hydraulic Diameter	Std Gate Hydraulic Diameter	
Number of Gates			

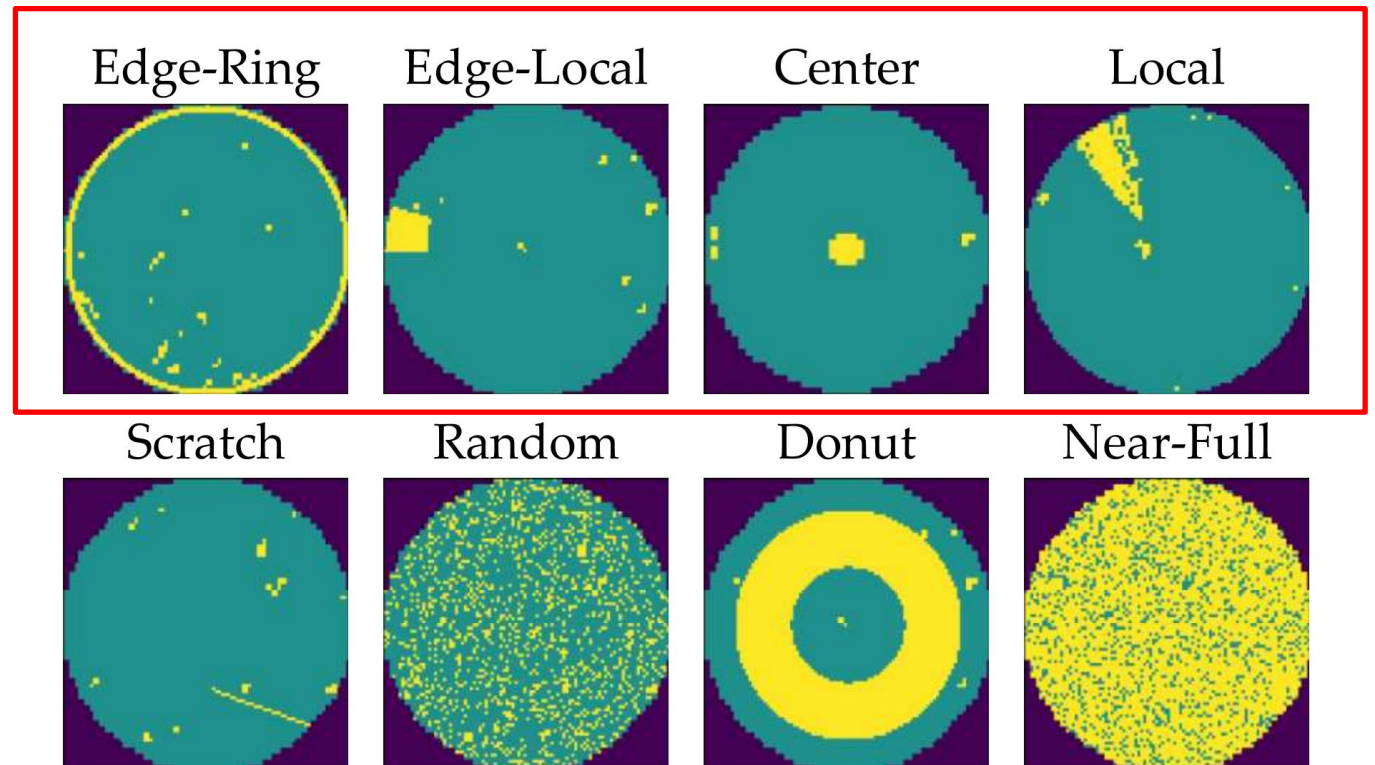
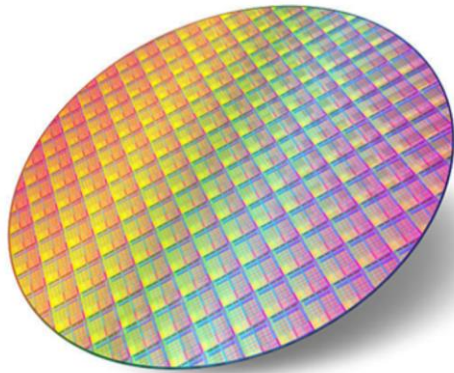
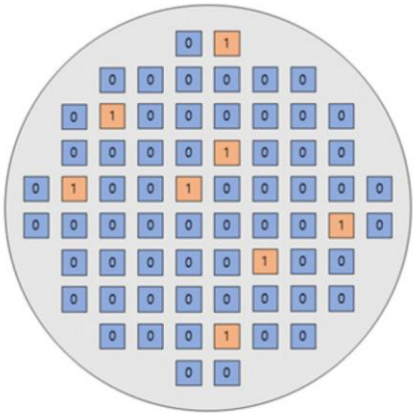
로컬 파일을 코랩으로 불러오기



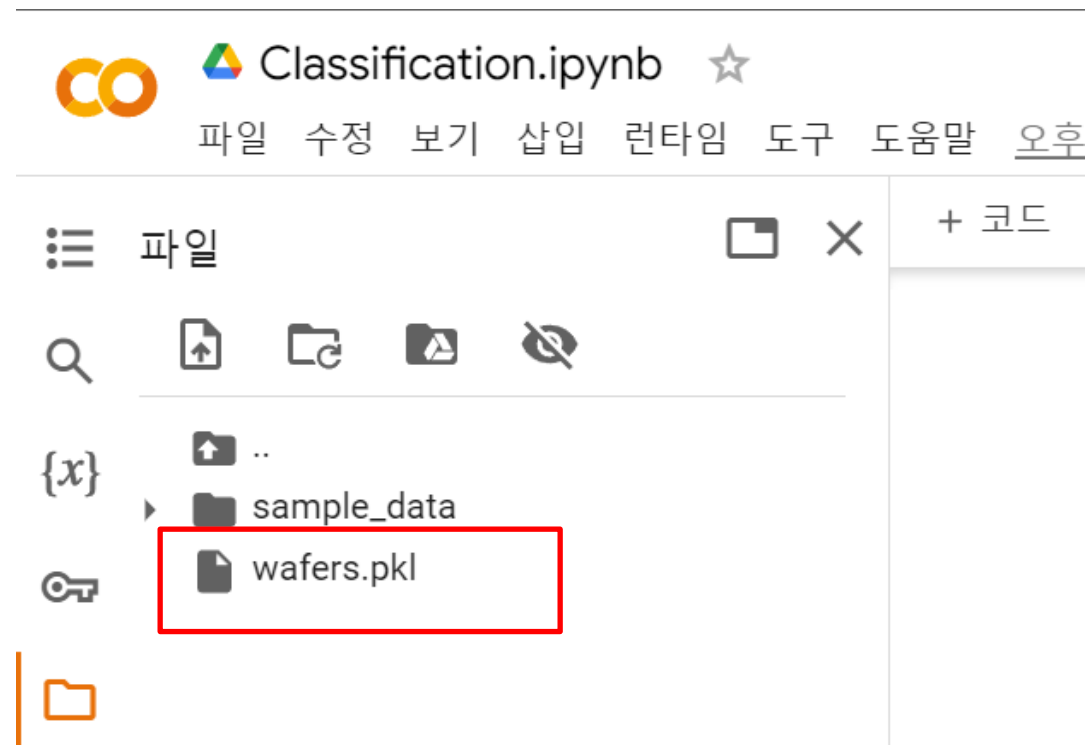
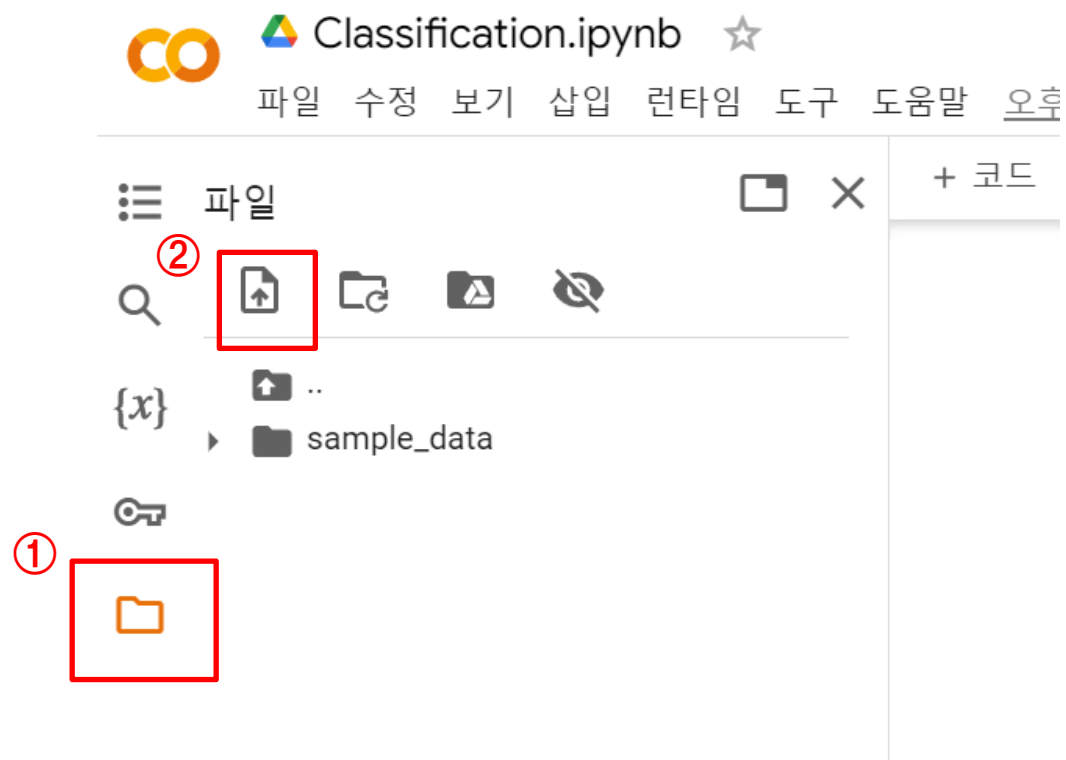
Classification (분류)

Semiconductor Wafer Failure Maps

- Identification of wafer failure pattern automatically
 - Input (x): Wafer failure map images (WM-811K)
 - Output (y): Failure pattern labels



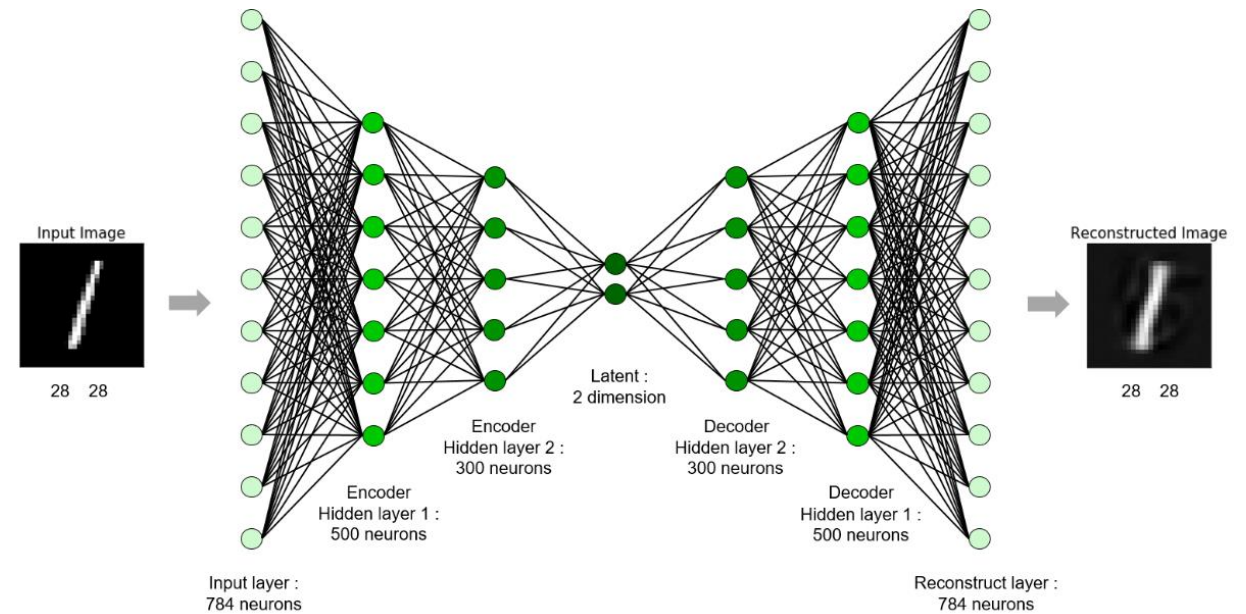
로컬 파일을 코랩으로 불러오기



Dimension Reduction (차원 축소)

MNIST

- Visualization of handwritten digits
 - Input (x): (1, 5, 6) digit images
 - Output (y): (1, 5, 6) digit images



MNIST Example: Walk in the Latent Space

